



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Hideki MATSUMURA, et al.

Serial No.: 10/041,609

Filed: January 10, 2002

For: **METHOD AND APPARATUS FOR DEPOSITING A THIN FILM, AND
SEMICONDUCTOR DEVICE HAVING A SEMICONDUCTOR-INSULATOR
JUNCTION**

Examiner: **BERRY, Renee R.**

P.T.O. Confirmation No.: 5375

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TECHNOLOGY CENTER
Group Art Unit: 2818-2800

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 11, 2003

Sir:

In response to the Office Action dated April 23, 2003, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.